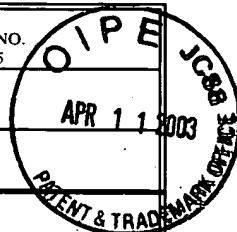


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1299		SERIAL NO. 09/428,125		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT Micron Technology, Inc.				
JAN 29 2002 PATENTS					FILING DATE October 26, 1999		GROUP 2822		
U.S. PATENT DOCUMENTS									
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
KL	AA	5,411,912	5-2-95	Sakamoto					
1	AB	5,508,221	4-16-96	Kamiyama					
	AC	5,876,788	3-2-99	Bronner					
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	AJ	6,180,481	1-30-01	DeBoer					
H	AK	6,197,653	3-6-01	Khamankar					
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FOREIGN PATENT DOCUMENTS									
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KL	AM	407161827A		Japan				Yes	No
KL	AN	405211288A		Japan					
	AO								
	AP								
	AQ								
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)									
	AR								
	AS								
	AT								
EXAMINER <i>J. Rose</i>				DATE CONSIDERED <i>6/12/03</i>					
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>									

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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Vishnu K. Agarwal et al.	
				FILING DATE October 26, 1999	GROUP 2822



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RF	AA	5,834,060	11-1998	Kawahara et al.			
	AB	5,760,474	06-1998	Schuele			
	AC	5,864,496	01-1999	Mueller et al.			
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							Yes	No
RF	AM	04162527A	06-1992	Japan				
RF	AN	403209869A	09-1991	Japan				
	AO							
	AP							
	AQ							

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RF	AR	Van Zant, "Microchip Fabrication: A Practical Guide to Semiconductor Processing" 4 th Edition, McGraw Hill 2000, pgs. 388-389.					
	AS						
	AT						

EXAMINER

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DATE CONSIDERED

4/12/03

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